



2813
\$

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Yamazaki, et al. Art Unit : 2813
Serial No.: 09/451,665 Examiner : Laura Schillinger
Filed : November 30, 1999
Title : SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD
THEREOF

Commissioner for Patents
Washington, D.C. 20231

TRANSMITTAL LETTER

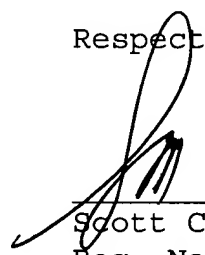
Correspondence relating to this application is enclosed.
The required fees are computed below. Please apply any charges
not covered, or any credits, to Deposit Account No. 06-1050.

Total Claims	82	-	56	=	26	\$468
Independent	10	-	8	=	2	\$160
TOTAL FEE DUE						\$628

A check for \$628 is attached.

Respectfully submitted,

Date: 8/8/01



Scott C. Harris
Reg. No. 32,030

Fish & Richardson P.C.
PTO Customer No. 20985
4350 La Jolla Village Drive, Suite 500
San Diego, CA 92122
Telephone: (858) 678-5070
Facsimile: (858) 678-5099

10126993.doc

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being
deposited with the United States Postal Service as first class mail with
sufficient postage on the date indicated below and is addressed to the
Commissioner for Patents, Washington, D.C. 20231.

TECHNOLOGY CENTER 2800
AUG 20 2001
RECEIVED

August 8, 2001
Date of Deposit

Signature

Susan Regan
Typed or Printed Name of Person Signing Certificate



Attorney's Docket No.: 07977/017002/US2968C1D1

#9/Amend C
a total
8/21/01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Yamazaki, et al. Art Unit : 2813
Serial No.: 09/451,665 Examiner : Laura Schillinger
Filed : November 30, 1999
Title : SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD
THEREOF

Commissioner for Patents
Washington, D.C. 20231

AMENDMENT

Sir:

In response to the Official Action dated May 9, 2001, Paper No. 8, in the above-referenced application, please amend the above-identified application as follows.

In the Claims:

Please amend the claims as follows.

RECEIVED
AUG 20 2001
TECHNOLOGY CENTER 2800

SUB
DI
C1
1. (Amended) A method of manufacturing a semiconductor device comprising the steps of:
forming a crystalline semiconductor film on an insulating surface;

03/17/2001 MWOLDER1 00000071 09451665

01 FC:102 160.00 OP
02 FC:103 460.00 OP

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.

August 8, 2001

Date of Deposit

Signature

Susan Regan

Susan Regan

Typed or Printed Name of Person Signing Certificate